



DRW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application: Tomoo Yamasaki et al. ] GRP ART UNIT: 2823  
Serial No: 10/776,864 ] Ex.: Coleman, William D.  
Filed: February 10, 2004 ]  
For: Substrate Fabrication Method and Substrate

Mail Stop Amendment  
The Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Mail Stop: Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

August 11, 2005  
Date

*M. Pomroy*  
Maggie Pomroy

**AMENDMENT**

Sir:

In response to the Office Action mailed May 17, 2005 for the above-identified patent application, please amend the application as follows:

**Amendments to the Drawings** begin on page 2 of this paper and include an attached replacement sheet and an attached annotated sheet showing the revisions.

**Remarks/Argument** begin on page 3 of this paper.